

# Design Considerations for Silicon Carbide Power

Silicon carbide (SiC) is a well-established device technology with clear advantages over silicon (Si) technologies, including Si superjunction (SJ) and insulated-gate bipolar transistors (IGBTs), in the 900-V to over-1,200-V high-voltage, high-switching-frequency applications. The recent introduction of the 650-V SiC MOSFET products has further broadened SiC use by easily replacing IGBTs, taking a bite out of the Si SJ application share and offering an alternative to gallium nitride (GaN) in the mid-voltage range.

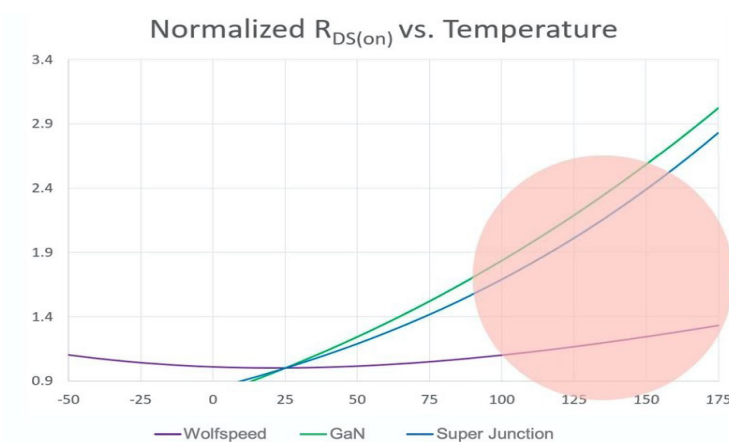
When replacing Si devices with SiC or designing anew with the latter, engineers must consider the different characteristics, capabilities, and advantages of SiC to ensure success. Here is a list of SiC design tips from the power experts at Wolfspeed.

## $R_{DS(ON)}$ Variance With Temperature

A key advantage of SiC is a low  $R_{DS(ON)}$  that changes as little as 1.3x to 1.4x over a wide temperature range, whereas in Si or GaN devices,  $R_{DS(ON)}$  may double to triple from that rated at 25°C to the practical junction temperatures in the 120°C to 140°C range (**Figure 1**). It is therefore important to carefully check the datasheet and specify the correct  $I^2R$  or conduction loss.

## No Knee Voltage

IGBTs are optimized for a thermal design point at the full rated current. Below that point lies the  $V_{CE(sat)}$  exponential “knee” voltage curve (**Figure 2**). SiC MOSFETs’ VDS characteristics are linear, offering lower conduction loss at any point lower than the full rated current.



**Figure 1:** A 60-mΩ Si or GaN device could be >120 mΩ hot, while a 90-mΩ SiC device would be 120 mΩ hot.

This is particularly useful to bear in mind when designing EV drivetrains, in which the drive cycle is mostly below the full rated power. When used in parallel, the IGBT  $V_{CE(sat)}$  curve exacerbates the problem.

Designers must therefore carefully consider where lies their thermal design point and mission profile.

## Effective Switching Frequency

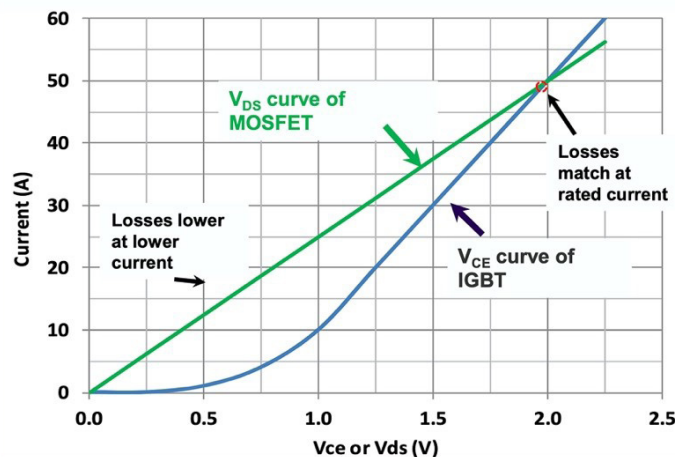
Effective switching frequency (ESF) is defined as the maximum frequency in a hard-switched application that a device can sustain at the rated  $I_{C100}$  with a 50% square-wave duty cycle without exceeding the device’s specified maximum power dissipation at working voltage. Or:

$$ESF = \frac{P_{Dmax}(1 - Duty\ Cycle)}{E_T}$$

### Where:

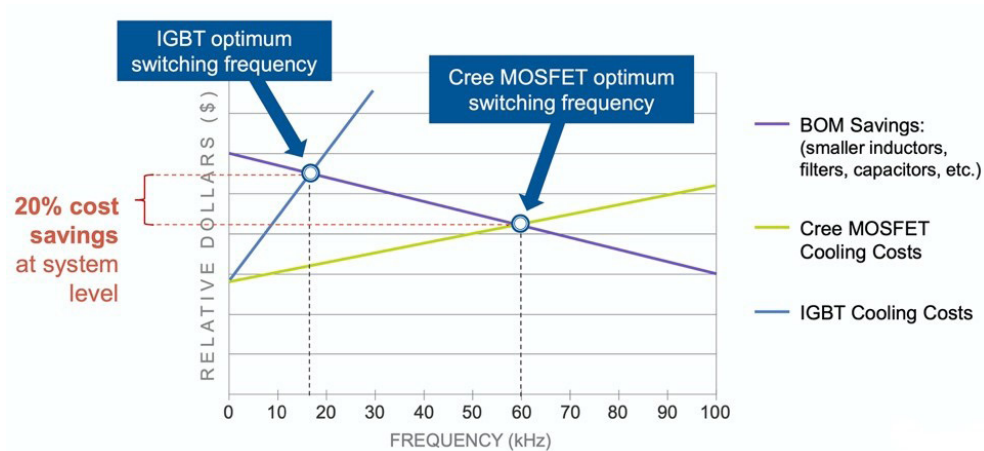
- $P_{Dmax}$  is the maximum power dissipation value,
- Duty Cycle is 50%
- $E_T$  is the total switching energy at 800 V, 175°C, and specified gate resistance ( $R_g$ ) in the data sheet.

The theoretical ESF of a 40-mΩ WolfSpeed SiC MOSFET compared with that of a 40-mΩ Si device is 10× higher. While this offers a glimpse into SiC’s capabilities, cooling, magnetics, and cost put practical limits to switching frequency.



**Figure 2:** Comparison of 50-A IGBT with 50-A SiC MOSFET in module at  $T_j = 150^\circ\text{C}$ . At one-third rated current, SiC’s losses are half those of the IGBT.

Cooling costs increase, but the passive BoM costs for inductors and capacitors decrease with switching frequency. For IGBTs, the optimum frequency is about 18 kHz, where the cooling and passive BoM savings curves intersect. For SiC MOSFETs, with their lower conduction losses, that sweet spot of cost tradeoffs is at about 60 kHz (**Figure 3**).



**Figure 3:** Frequency optimization takes into account practical limits on switching frequency from cooling and BoM costs.

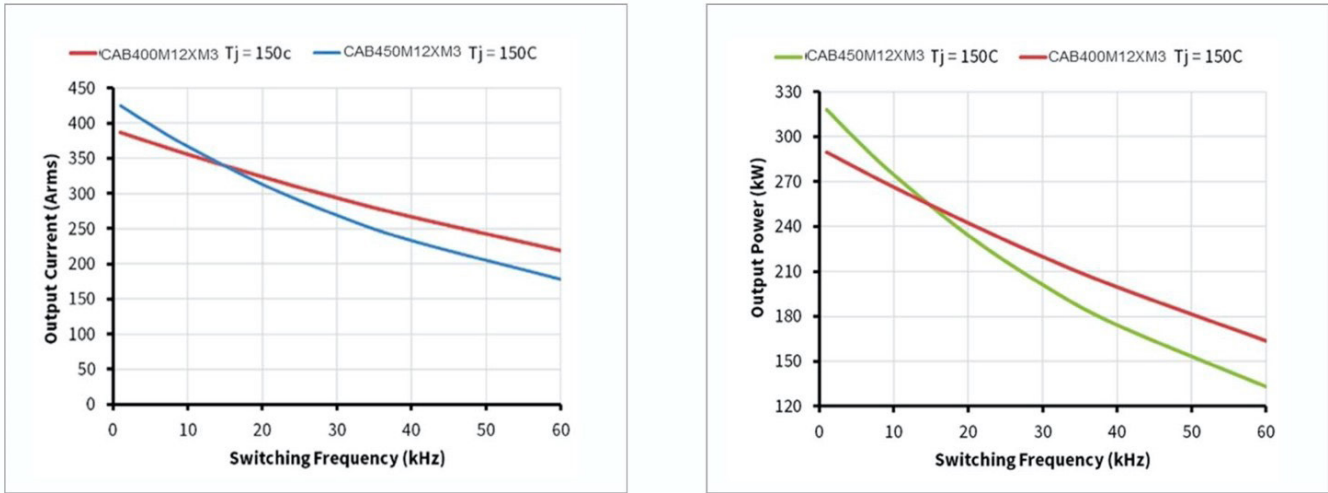
Designers must note that there is a limit to minimizing the inductors, particularly if the system is tied to the grid. And while SiC devices themselves are more expensive than IGBTs, a frequency-optimized design sees a 20% to 25% cost savings at the system level.

## Optimizing for Applications

The figure of merit (FoM) for a MOSFET is defined by the equation below. The idea behind it is that lower  $R_{DS(ON)}$  means lower conduction losses, while lower gate charge,  $Q_g$  means lower switching losses. Total losses are minimized if their product, FoM, is minimized.

$$FoM = R_{DS(ON)} \times Q_g$$

An examination of the output current and output power versus switching frequency characteristics of two of Wolfspeed’s highest-power-density power modules reveals how designers must carefully select the optimal product for their application (**Figure 4**). The 450-A CAB450M12XM3 module is optimized for very low  $R_{DS(ON)}$ , but the 400-A CAB400M12XM3 module is optimized for FoM. Over 15 kHz, the 400 A delivers higher current and higher power.



**Figure 4:** For this notional example,  $F_{sw}$  is 15 kHz. After the crossover point, CAB400M12XM3 can deliver higher amperage than CAB450M12XM3.

For a motor drive typically operating below 20 kHz, the higher-amperage module is effective, but for solar power inverters switching in the 48-kHz to 60-kHz range, the 400-A module is a better choice.

## $V_{DS}$ Ruggedness & Derating

IGBTs are typically rated at 1.2 kV, with VDS breakdown voltage close to 1.25 kV. Wolfspeed’s SiC MOSFETs, while rated at 1.2 kV, typically have breakdown voltages several hundred volts higher. In aerospace applications, in which designers must derate to account for the effects of cosmic radiation, SiC’s robustness offers an advantage.

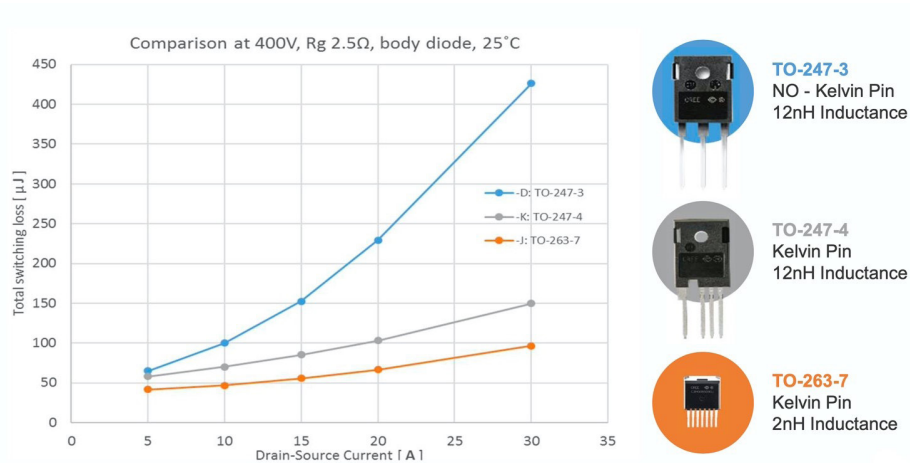
## Reverse Recovery

Designers may not pay as much attention to it when soft-switching or using asymmetric designs, but reverse recovery ( $Q_{rr}$ ) is important for symmetrical designs, including buck, boost, and totem-pole PFCs. A Wolfspeed 650-V SiC MOSFET would have an 11-nC  $Q_{rr}$  for a reverse-recovery time,  $T_{rr}$  of 16 ns compared with a typical 650-V Si MOSFET that has a 13- $\mu$ C  $Q_{rr}$  for a  $T_{rr}$  of 725 ns.

## Kelvin Source Pin

The Kelvin source pin — a Kelvin connection that is as close as possible to the source connection of the MOSFET die — is used to mitigate inductance due to internal bond wires of the MOSFETs. To maintain the high switching frequency advantage of SiC devices, the Kelvin source pin is critical.

The Kelvin source pin also affects switching loss. For instance, at 30-A  $I_{DS}$ , the total switching loss in a TO-247-3 SiC MOSFET with no Kelvin pin and 12-nH source inductance is close to 430  $\mu\text{J}$  (**Figure 5**). The same product in a TO-247-4 package – with a Kelvin source pin – has merely 150  $\mu\text{J}$  of switching loss at the same  $I_{DS}$ . Moving to a smaller package like the TO-263-7 or the surface-mount D2PAK-7 further reduces the inherent source inductance and the losses.



**Figure 5:** The Kelvin source pin helps avoid the inductance in the gate driver loop and reduces switching energy loss.

## Gate Drive Considerations

When driving SiC MOSFETs, designers must remember that a negative gate drive is needed to ensure a hard turnoff, unlike with silicon, in which a positive gate drive is used to turn on the device. Other SiC-specific factors to remember include:

- Faster  $dV/dt$  and rated common-mode transient immunity (CMTI) of  $>100 \text{ kV}/\mu\text{s}$
- Peak continuous working voltage ( $V_{IORM}$ ) of up to 1.7 kV
- Driving capability that is generally higher power and up to 10 A
- Propagation delays and channel mismatch time typically  $<10 \text{ ns}$
- Active Miller clamp requirement because of higher switching speeds and a slightly lower threshold at 2 V
- A fast short-circuit protection because of smaller SiC die size ( $<1.8 \mu\text{s}$ )

Beyond this, driving SiC devices is much like driving Si-based devices.

## Dealing with EMI

Because target switching frequencies are usually higher for SiC devices, and their rise and fall times are much shorter than those of Si products, engineers may be inclined to believe that this would cause greater EMI issues.



However, there is no effect on the low-frequency noise or the differential mode EMI filter size required compared with Si. While there is an effect on the conduction mode noise on the input terminal, it is only in the megahertz range. This high-frequency EMI can be attenuated, just like with Si-based devices, by using high-frequency material and capacitor for EMI suppression.

## **A wide range of applications**

SiC devices are used today in applications ranging from 200-kW UPS, 180-kW EV drivetrains, and 10-kW solar inverters down to 220-W LED SMPS, all designed while keeping in mind a few SiC design considerations and the usual good design principles.



## References

1. Guy Moxey, "A Designer's Guide to Silicon Carbide Power", <https://www.wolfspeed.com/knowledge-center/article/a-designer-s-guide-to-silicon-carbide-power>